

# Toshihiro Takeshita

## List of Publications by Year in descending order

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9  
papers

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1937685  
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42  
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#	ARTICLE	IF	CITATIONS
1	Simulation and fabrication of a MEMS optical scanner device considering deformation caused by internal stress. Japanese Journal of Applied Physics, 2016, 55, 10TA11.	1.5	8
2	High-efficiency MOSFET bridge rectifier for AlN MEMS cantilever vibration energy harvester. Japanese Journal of Applied Physics, 2017, 56, 04CC03.	1.5	6
3	Soft-rubber-packaged Pb(Zr,Ti)O <sub>3</sub> MEMS touch sensors for human-machine interface applications. Japanese Journal of Applied Physics, 2017, 56, 04CC04.	1.5	5
4	Fabrication of an ultrathin lead zirconate titanate mirror device mounted on flexible substrate. Japanese Journal of Applied Physics, 2017, 56, 10PF11.	1.5	5
5	Flexible substrate with floating island structure for mounting ultra-thin silicon chips. Flexible and Printed Electronics, 2020, 5, 025001.	2.7	5
6	Development of ultra-thin MEMS micro mirror device. , 2017, , .		4
7	Ultra-thin PZT/Si chip integrated on paper substrates. Japanese Journal of Applied Physics, 2021, 60, SFFB12.	1.5	2
8	Development of Flexible Haptic Device Based on Ultra-Thin PZT/Silicon Vibrator Array. , 2021, , .		1
9	Flexible Parametric Speaker with Ultra-Thin PZT/Si MEMS Chips Integrated On Paper Substrate. , 2022, , .		0